



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: James Gary PRUETT, et al. Docket No.: HTI.P.8213
Serial No.: 10/621,478 Examiner: Elizabeth M. COLE
Filed: 7/17/2003 Group Art Unit: 1771
Title: Continuous Chemical Vapor Deposition Process And Process Furnace

**MAIL STOP AMENDMENT
COMMISSIONER FOR PATENTS
P.O. Box 1450
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I hereby certify that this correspondence is being deposited on the date shown below with the United States Postal Service as first class mail in an envelope with sufficient postage addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Laura A. Rafin
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Laura A. Rafin
(signature of person mailing paper)

11-20-06
(date)

TRANSMITTAL SHEET

Enclosed are:

Transmittal Sheet with Certificate of Mailing and Authorization to Charge Deposit Account
(1 page – in duplicate)
Response B to Office Action (6 pages)
Petition for Extension of Time (1 page – in duplicate)
Check in the Amount of \$120.00
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AUTHORIZATION TO CHARGE DEPOSIT ACCOUNT

In the event an additional fee is applicable to the filing of this document and the required fee is not enclosed, or the fee submitted is insufficient, the Director is hereby authorized to charge any fees for HTI.P.8213 that might be required to effect the filing of this (these) documents to Account No. 50-3275. This certificate is submitted in duplicate.

Respectfully submitted,

Salvatore A. Sidoti
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Date 11-20-06

Customer No. 23575



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Applicants: James Gary PRUETT, et al. Docket No.: HTI.P.8213
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Laura A. Radt
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(signature of person mailing paper)

11-20-06
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RESPONSE B

I. INTRODUCTORY COMMENTS

To the Honorable Commissioner For Patents:

Applicants, through their attorney, hereby respectfully respond to the Office Action mailed July 20, 2006 and respectfully request reconsideration of the present application.

The present Response is accompanied by a Petition for a one month extension of time and a check in the amount of \$120.00.

Remarks begin on page 2 of this paper.